

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

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**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(Use several sheets if necessary)

37 CFR 1.98(b)

APPLICANT  
Xavier Jean-François LEVECO et al.

FILING DATE  
November 2, 2001

GROUP  
2877

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT NO.	ISSUE DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA					
	AB					
	AC					
	AD					
	AE					
	AF					

**FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION**

	DOCUMENT NO.	PUBL. DATE	COUNTRY OR PATENT OFFICE	CLASS	SUB CLASS	TRANSLATION YES
DBE	AI 197 05 119 A1	08/98	DE			With English Summary
	AJ					
	AK					
	AL					
	AM					
	AN					

**OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)**

DBE	AT	Michael C. Roggemann et al., "Algorithm to Increase the Largest Aberration that Can be Reconstructed from Hartman Sensor Measurements," <u>APPLIED OPTICS</u> , v. 37, 1998, PP. 4321-4329.
	AU	
	AV	
	AW	

EXAMINER

*D. Bigler*

DATE CONSIDERED

4/9/03

EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.